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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Zvi OR-BACH et al.

Appl. No. 10/730,064

Filed: December 9, 2003

For: N

METHOD FOR FABRICATION

OF SEMICONDUCTOR DEVICE

Art Unit: TBD

Examiner: TBD

Atty. Docket No. 38897-199163

Customer No.

26694

PATENT TRADEMARK OFFICE

## **Preliminary Amendment**

Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants kindly request that the amendments set forth in the following pages be entered prior to examination of this application. It is not believed that any fees are due in connection with these amendments. However, should there be any fee deficiency, please charge such fee deficiency to our Deposit Account No. 22-0261.

Applicant: OR-BACH et al. Appl. No. 10/730,064

## Amendments

Amendments to the Specification begin on Page 3 of this paper.

Amendments to the Drawings begin on Page 4 of this paper.

Remarks begin on Page 5 of this paper.

An **Appendix** containing amended drawing figures, as well as formal versions of the non-amended drawing figures, follows, beginning with Page 6 of this paper.